

Form PTO-1449		ATTY. DOCKET NO. 0171-1061P	APPLICATION NO. NEW						
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <small>(Use several sheets if necessary)</small>		APPLICANT HARADA, Yuji et al							
		FILING DATE February 9, 2004	GROUP						
<b>U.S. PATENT DOCUMENTS</b>									
EXAMINER INITIAL	DOCUMENT NUMBER	KIND	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE		
RA	US 4,491,628		1985-01-01	Ito et al.					
RA	US 5,310,619	A	1994-05-10	Crivello et al.					
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<b>FOREIGN PATENT DOCUMENTS</b>									
EXAMINER INITIAL	OFFICE	DOCUMENT NUMBER	KIND	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
								YES	NO
RA	JP	2-27660 ✓	B2	1990-06-19	JAPAN			ABS	
RA	JP	63-27829 ✓	A	1988-02-05	JAPAN			ABS	
RA	JP	9-73173 ✓	A	1997-03-18	JAPAN			ABS	
RA	JP	10-10739 ✓	A	1998-01-16	JAPAN			ABS	
RA	JP	9-230595 ✓	A	1997-09-05	JAPAN			ABS	
RA	WO	97/33198 ✓	A1	1997-09-12	WO			ABS	
RA	JP	2001-146505	A	2001-05-29	JAPAN			ABS	
<b>OTHER DOCUMENTS</b> <small>(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)</small>									
RA	Hiroshi, Ito et al., "Polymer design for 157 nm chemically amplified resists", SPIE 2001, Proceedings 4345-31, Pages 273-285								
EXAMINER	P. Ashton			DATE CONSIDERED				10-11-04	
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with N.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>									